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Mapping of structural changes induced by X-ray nanopatterning via nano-XRD and corresponding electrical effects

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Abstract

We have investigated the modifications induced in high- T_c superconductor $\text{Bi}_2\text{Sr}_2\text{CaCu}_2\text{O}_{8+\delta}$ (Bi-2212) single crystals by irradiation with an X-ray nanobeam $250 \times 250 \text{ nm}^2$ in size with $E=14.85 \text{ keV}$ and a time-averaged photon flux $\Phi_0 = 7.53 \times 10^8 \text{ ph s}^{-1}$. Crystals have been mounted onto amorphous substrates with electrical contacts to allow for both XRD and electrical measurements on the same sample. Changes in the domain structure have been monitored via space-resolved nano-XRD mapping, whereas electrical properties have been measured offline at different levels of irradiation dose. The results show that irradiation induces both an increase of the mosaicity spread and a localized release of the mechanical stress of the crystals. This implies a transient local change of mechanical properties that could be due to thermal fatigue or non-thermal melting. Analysis of the electrical properties of the irradiated regions indicates a strong underdoping effect by the nanobeam and an exponential increase of the normal-state resistivity with the irradiation dose, according to the average rate $\alpha = (1.48 \pm 0.12) \times 10^{-11} \text{ Gy}^{-1}$. These results represent an important step towards the full development of the X-ray nanopatterning technique.

Keywords: synchrotron, nanobeam, direct-write patterning, high-temperature superconductors, Bi-2212, oxygen, grain boundary, X-ray nanopatterning

1. Introduction

In the field of electronics based on the complementary metal oxide semiconductor (CMOS) technology, during the past few decades the efforts to keep the pace of Moore's law have implied a general trend towards miniaturization of the transistor components in order to achieve lower power consumption and higher integration density. However, it is apparent that when approaching the length scale of solid-state interatomic distances many issues are expected to arise. For instance, larger impedances and fluctuations can be predicted, and this is the reason why the 10-nm technological node has seen the gradual use of germanium and III-V compounds instead of pure silicon for the transistor channels, because of their higher mobility.¹

On the other hand, from the point of view of the patterning techniques, this trend has naturally pointed towards the use of shorter and shorter radiation wavelengths λ for the photolithographic processes in order to achieve higher and higher resolutions R , according to the Rayleigh criterion $R = k \lambda / \text{NA}$. Unfortunately, this route has encountered major problems concerning the power of the radiation sources, the requirements for mask contrast and alignment, and about the resist resolution. As an example, in the case of $\lambda \lesssim 10$ nm (i.e. in the soft X ray regime), a proximity X-ray lithography technique very similar to ordinary optical photolithography has been tested,² but the need for a very tight control over the mask-substrate separation, mask deformation problems, and sensitivity to vibrations during the masking process have prevented it to be adopted for mass production. Another example is represented by the electron beam lithography (EBL), which routinely achieves very good resolutions due to the extremely short De Broglie wavelength, but so far has not been able to overcome the limits of slow speeds and ineffectiveness for 3D fabrication. Therefore, nowadays complicated multiple patterning photolithographic processes exploiting the $\lambda = 193$ nm radiation of ArF lasers still represent the reference technology for the mass production of 10-nm chips.

However, in all of the above-mentioned examples the use of some photoresists is implied and an additional pattern transfer step is needed after exposure and development to complete the nanofabrication process via subsequent etching or deposition. Actually, in recent times the increasing availability of intense radiation sources with nanometric spot size, in principle, has made it possible to imagine another photoresist-free nanofabrication approach based on the direct interaction between the chip material and the radiation, because the corresponding very high energy density is able to directly modify the material properties. Indeed, it has been observed many times that synchrotron radiation is able to

trigger phenomena like photoreduction,³ photodissociation,⁴ phase transition⁵ or crystallization,⁶⁻⁷ which can radically change structure and properties of the irradiated materials. In this respect, the come into service of the 4th generation synchrotron radiation sources⁸ is expected to push the energy density at even higher limits where new states of matter should become accessible, making these phenomena more and more important and opening new possibilities for their exploitation.

In the past, our group has also observed some modifications in high- T_c superconducting oxides like $\text{Bi}_2\text{Sr}_2\text{CaCu}_2\text{O}_{8+\delta}$ (Bi-2212) and $\text{YBa}_2\text{Cu}_3\text{O}_{7-x}$ (YBCO), where we showed that irradiation with X-ray nanobeams is able to change the length of the c -axis lattice parameter, the electrical resistivity, and the critical temperature T_c .⁹⁻¹⁴ Following this general idea, we have successfully exploited these changes to pattern some superconducting devices via a direct-write X-ray nanopatterning technique.¹⁵⁻¹⁶ That was an important development because, in principle, this method could offer interesting advantages in terms of simplicity, real-time monitoring during device fabrication, better heat dissipation and absence of chemical contaminations.

Even though we have already extended this approach also to a semiconducting material like TiO_2 ,¹⁷ nevertheless the microscopic mechanisms responsible for the material modifications are not known yet. Among the ones that we have already investigated, it has become increasingly clear that both the oxygen knock-on and the local heating induced by the photoelectron cascades can only play quite a limited role.¹⁸⁻¹⁹

A better knowledge of these mechanisms and how they affect the material micro- and nano-structure is absolutely needed for the improvement of this X-ray nanopatterning method.

Therefore, the goal of the present paper is represented by increasing the knowledge about the structural changes induced at the micron and sub-micron scale by X-ray irradiation in a superconducting oxide, and how these changes correlate with the corresponding modifications in the normal-state and superconducting electrical properties.

2. Experimental setup and procedures

Bi-2212 whiskers were grown according to the glassy precursor route.²⁰⁻²¹ High purity commercial oxides Bi_2O_3 , SrCO_3 , CaCO_3 and CuO were thoroughly mixed in the Bi:Sr:Ca:Cu ratio of 1.5:1:1:2, then put into a crucible and melted at 1150°C in air for 30 minutes. Glassy plates were produced by quenching the melt between two copper plates at room temperature, then the crystal growth took place by annealing these plates at 850°C

for 120 h in a constant oxygen flow via a growth mechanism involving shape and size changing, moving and multiple growth interfaces.²²⁻²³

This process produces microscopic parallelepiped crystals of Bi-2212 with an orthorhombic structure and facets (001), (010) and (100). The typical lengths of these microcrystals are very anisotropic (about 500 μm along the a -axis, 10 μm along the b -axis and about 1 μm along the c -axis), consequently, they can be oriented simply by inspection.

Well-straight and defect-free crystals were selected at the optical microscope ($100\times$ magnification) for device fabrication and mechanically transferred onto glassy substrates, which were chosen to avoid spurious contributions of the diffraction pattern. The c -axis of the crystals was always oriented normal to the substrate. Four Ag electrical contacts (2.1 μm in thickness) have been deposited on each crystal by means of physical vapour deposition through a metallic shadow mask. In order to secure good electrical contact with the crystals without changing their oxygen stoichiometry, samples underwent an annealing procedure at 450°C in pure oxygen atmosphere, with heating and cooling rate equal to 5 K min⁻¹.²⁴ At least two Pt markers (pillars) about $1\times 1\times 1\ \mu\text{m}^3$ in size have been fabricated in each sample, close to the region of interest, in order to introduce reference points to facilitate the alignment during the synchrotron experiments. These markers were deposited via focused-ion-beam (FIB)-assisted vapour deposition with a FEI Quanta 3D system, using a Ga-ion current of about 10 pA. Fig. 1(a) and 1(b) show a scanning electron microscope (SEM) image and a geometrical sketch of the typical sample region located between the voltage contacts, respectively.

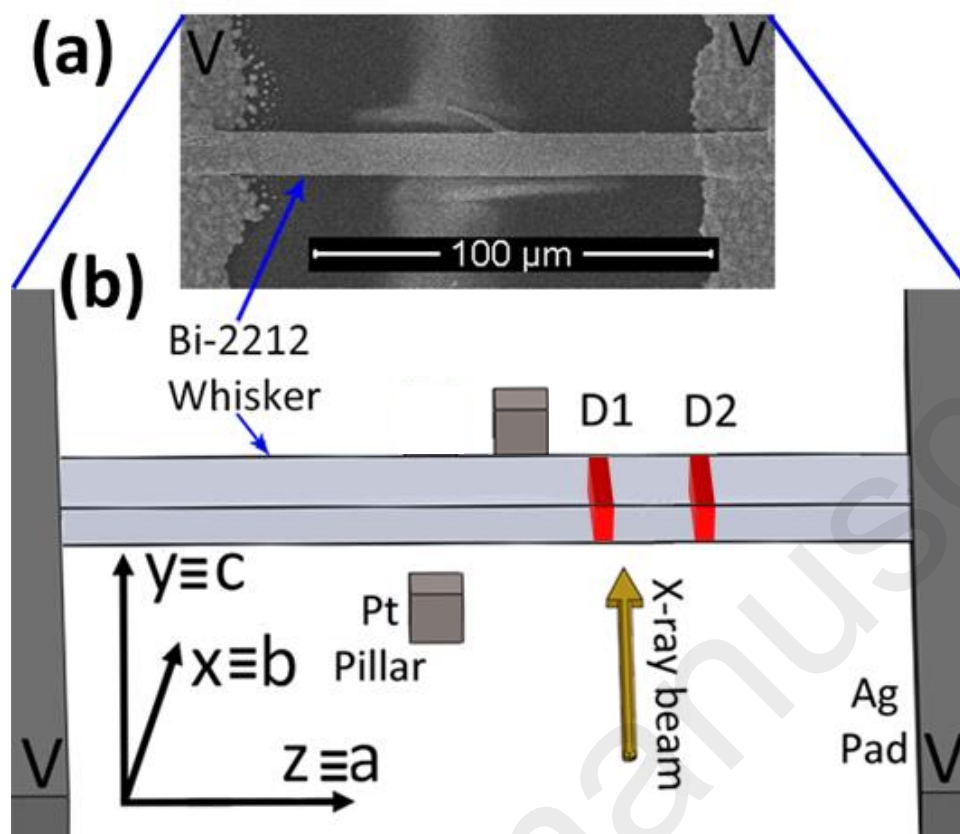


Fig. 1. (a) SEM image of a typical Bi-2212 micro-crystal mounted on a chip for XRD, X-ray irradiation and 4-probe electrical measurements (only the portion of the crystal between the two voltage electrodes V is shown). (b) Schematic representation of a sample with two damaged positions (D1 and D2) highlighted in the Bi-2212 crystal. Two Pt markers (pillars) are also indicated (not visible in panel (a)). The reference system shows the relative orientation of the laboratory frame of reference (x , y and z) and of the Bi-2212 crystal axes (a , b and c).

Both XRD acquisition and X-ray irradiation sessions were carried out at the ID13 beamline of the European Synchrotron Radiation Facility (ESRF) in Grenoble, France. This is a long-canted beamline with the experimental hutch (EH3) placed about 100 m downstream of the undulator. The experiment was carried out at the energy $E=14.85$ keV with a time-averaged photon flux $\Phi_0=7.53\times 10^8$ ph s^{-1} in the 7/8+1 filling mode for the storage ring. The sizes of the beam spot used for our experiments were 250×250 nm², and details about the monochromator and the focusing optics are reported in Ref.²⁵. Motorized positioners for the samples form a stack consisting, from bottom to top, of a rotational stage (ϕ -coordinate) with its rotation axis perpendicular to the storage ring, a hexapod, and a three-dimensional translation (x,y,z -coordinates) piezoelectric stage for high-resolution sample scanning (see Fig. 2). Samples have been mounted on the piezo-stage and placed with their crystallographic a -

axis coinciding with the rotation axis of the setup. A microscope with the optical axis coinciding with the beam and a fluorescence detector have been used for sample location and pre-alignment. XRD data have been acquired by means of an EIGER X 4M hybrid pixel detector from DECTRIS with $75 \times 75 \mu\text{m}^2$ pixel size and $3 \mu\text{s}$ dead time. The detector has been placed at about 360 mm from the sample and horizontally translated in order to improve angular resolution and to avoid the impingement of the direct beam (see Fig. S1 of the Supplementary Information). Precise position and distance with respect to the beam and to the sample have been evaluated by using the average of 100 diffraction patterns obtained from different positions of a boron glass capillary 0.1 mm in diameter and filled with standard corundum powder (NIST 676a), and from the refinement algorithm implemented in the FIT2D code.²⁶ Typical XRD characterization procedures are represented by y, ϕ -scanning and y, z, ϕ -scanning, which have been used to determine sample fine orientation and twist, and y, z -scanning at fixed rotation angle ϕ , which has been exploited to localize the different crystal domains. In order not to induce unwanted damage in the samples, during characterization measurements the exposure time has been kept as short as 20-50 ms per point.

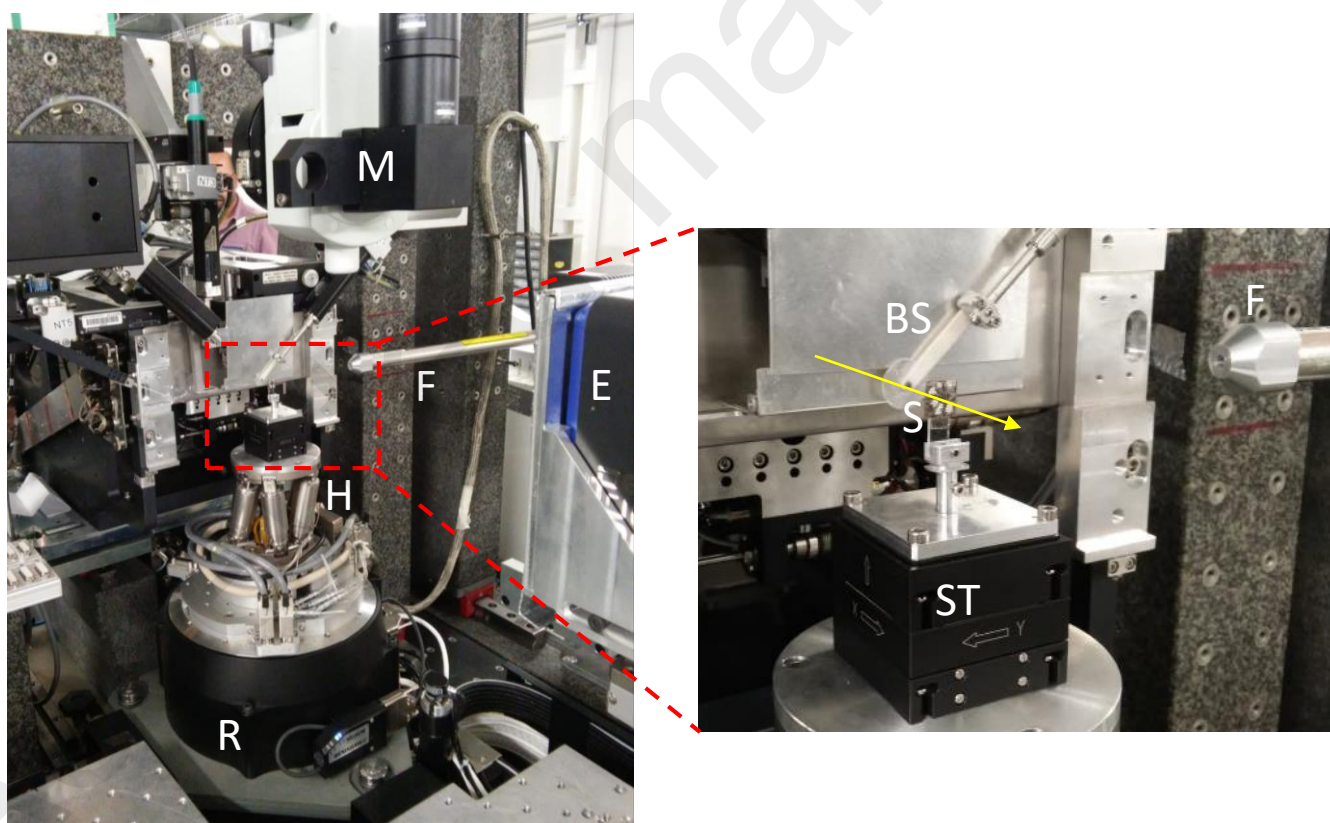


Fig. 2. End-station of the experimental setup in the experimental hutch EH3 of the beamline ID13 at ESRF. The yellow line represents the X-ray nanobeam. S indicates the sample, BS the beam stopper, ST the sample stage, F is the fluorescence detector, M the alignment optical microscope, H indicates the hexapod, R the rotation stage, and E the Eiger X 4M detector.

Off-line electrical characterization of the samples has been carried out by using the four electrical probes deposited on every chip, measuring the voltage drop along the crystallographic a -axis. The electrical resistance R was measured as a function of the temperature T in a continuous He flow Janis ST-100 cryostat in the temperature range 40-295 K during temperature ramps performed on warming at a constant rate (0.7 K min^{-1}). Samples have been fed with a constant current in the range 1-20 μA (depending on sample conditions) and the voltage drop was monitored by a Keithley 182 digital voltmeter.

The experimental protocol has consisted in: i) R vs T characterization of each sample before X-ray irradiation; ii) XRD characterization of the sample in pristine conditions; iii) prolonged X-ray irradiation of a selected region of the sample; iv) repetition of the XRD characterization for the irradiated region and its surroundings; v) repetition of R vs T characterization after sample irradiation. Stages from ii) to v) were expected to be repeated at least for another unirradiated portion of the same sample. However, due to constraints related to the available beamtime, this repetition has been possible for a single sample (WBL24), whereas another sample (WBL03) went only through step i) to v). Other samples were not able to go beyond stage iv), and therefore will be excluded from the present paper.

The most interesting samples were also characterized after the irradiation process through atomic force microscopy (AFM) in a Cypher S system by Asylum Research available at the Partnership for Soft Condensed Matter (PSCM) of ESRF.

3. Data treatments, results and discussion

Bi-2212 features a complex, incommensurably modulated, layered structure with superspace group $Bbmb$ ($0\beta 1$) and a pseudo-tetragonal cell ($a \approx b \approx 5.4 \text{ \AA}$, $c \approx 30.7 \text{ \AA}$) with modulation vector $q^* = (0, 0.210, 1)$.²⁷ The over-stoichiometric oxygen content δ , due to oxygen atoms hosted in an interstitial site between the BiO and SrO layers,²⁷ strongly affects the transport properties by doping the system with holes. For instance, an increase of δ induces a decrease of the normal state electrical resistivity and also affects its critical temperature T_c . The highest T_c (optimal doping regime, OP) corresponds only to a specific δ value, whereas both higher and lower values induce lower T_c 's (overdoped regime, OD, and underdoped regime, UD, respectively).

In the present paper, all of the XRD scanning acquisitions have been subjected to image treatment procedures via a Python code developed *ad hoc* (based on NumPy and Matplotlib libraries). Indeed, the use of a 2D detector jointly with n -dimensional scanning ($n = 2,3$ for y,z - or y,z,ϕ - scanning, respectively) produces a set of $2+n$ -dimensional data matrixes that is very difficult to be represented on two-dimensional supports. Two main procedures have been applied to simplify the analysis: the

former consists in performing a pixel-wise maximum projection along one or more axes of the matrix by selecting for each pixel of the detector the maximum intensity recorded over the whole data set originated during the scanning, generating a so-called *maximum intensity projection* image. The latter consists in integrating the recorded intensity over a selected area of the detector for every single image acquired during the scanning, and in plotting this integrated intensity as a function of the acquisition coordinates in order to obtain a *localization map* of the diffracted intensity.

The samples have been pre-aligned at the optical microscope with the whisker a -axis perpendicular to the electric polarization of the beam and the b -axis parallel to the beam. Subsequently, this pre-alignment has been slightly refined by using the Pt pillars deposited on the substrate. Indeed, their positions represent a reference point close to the region of interest and their small displacement along the a -axis of the whisker in the fluorescence maps allows to align the surface of the substrate parallel to the direction of the beam. The full alignment has been carried out directly by means of the Bi-2212 diffraction patterns following a procedure based on a series of ϕ -scans and peak integrations. The first step consists in centering the beam on the crystal via fluorescence map acquisitions and performing a ϕ -scan of about 10 - 20° in steps of 0.2° . This relatively small angular range keeps the sample always illuminated by the beam although it is not perfectly aligned to the center of rotation, and at the same time allows to satisfy the reflection condition for several $(00l\ n)$ reflections. The series of images obtained by this initial ϕ -scan has been maximum projected along the rotation coordinate obtaining the typical picture shown in Fig. S2 of the Supporting Information. This figure allows to index the reflections using the d -spacing and to localize the detector region of interest (ROI) where the peak of interest (POI) to be selected for whisker monitoring falls. After defining the detector ROI, a preliminary ϕ angle at which the POI was in diffraction condition was determined by using a 1D *localization map* along the ϕ coordinate only (i.e., actually, a *localization curve* or rocking curve, see Fig. S4). Successively, more precise ϕ values for the POI have been obtained via finer ϕ -scans just around the preliminary position found.

As a reference case, we discuss in detail the XRD results concerning the sample with the most complete data set (WBL24).

The pristine state of the sample has been characterized by a y,z,ϕ -scanning with a spatial sampling resolution of 200 nm for both the y and z coordinates, and 0.05° for the ϕ coordinate. Fig. 3(a) shows the maximum intensity projection of reflection $(006\ 1)$, which has been selected as the POI for data analysis. In order to determine the possible crystal twist induced by the sample preparation procedures, we have calculated the localization map of the peak intensity integrated over the detector area reported in Fig.3(a), with the additional step of summing up all the integrated intensities obtained at any fixed (z, ϕ) coordinate pair but corresponding to different y values. In other words, to increase

the statistics, we have integrated along the short direction of the crystal $c \cong y$, whose length is about 650 nm, as determined from SEM observation, which corresponds just to about 3 data sampling in this direction. The corresponding (double-integrated) localization map is reported in Fig. 3(b). It can be noticed that the optimal ϕ angle for this reflection changes linearly along the $z \cong a$ -axis of the whisker, suggesting a constant twist with a value of $0.038^\circ \mu\text{m}^{-1}$, corresponding to the crystal habitus schematically represented in Fig. 3(d). This deformation could have been originated from the operations related to the mechanical mounting of the crystal on the measurement chip and to the fabrication of electrical contacts.

The c -axis lattice parameter has also been determined by averaging the values calculated from the d -spacing of the reflections (006 0), (008 0), (0010 0), (0012 0), (0014 0), and (0016 0). Each d -spacing has been obtained evaluating the centroid position on the curves resulting from the radial integration of a maximum projection of a $10\text{-}20^\circ$ ϕ scan with a fine step. The value obtained for the crystal in this pristine condition is $c = 30.536(5)$ Å, which corresponds to a heavily OD regime.²⁸⁻²⁹

The crystal position selected for the first damage process (labelled as D1) has been located in the center of the explored region. A rocking curve of reflection (006 1) was measured with an angular resolution of 0.01° at this position revealing a $\text{FWHM} \cong 0.06^\circ$, which testifies a very good crystallinity of this sample that is comparable to the free-standing Bi-2212 crystals analyzed by our group in a previous experiment.²⁹

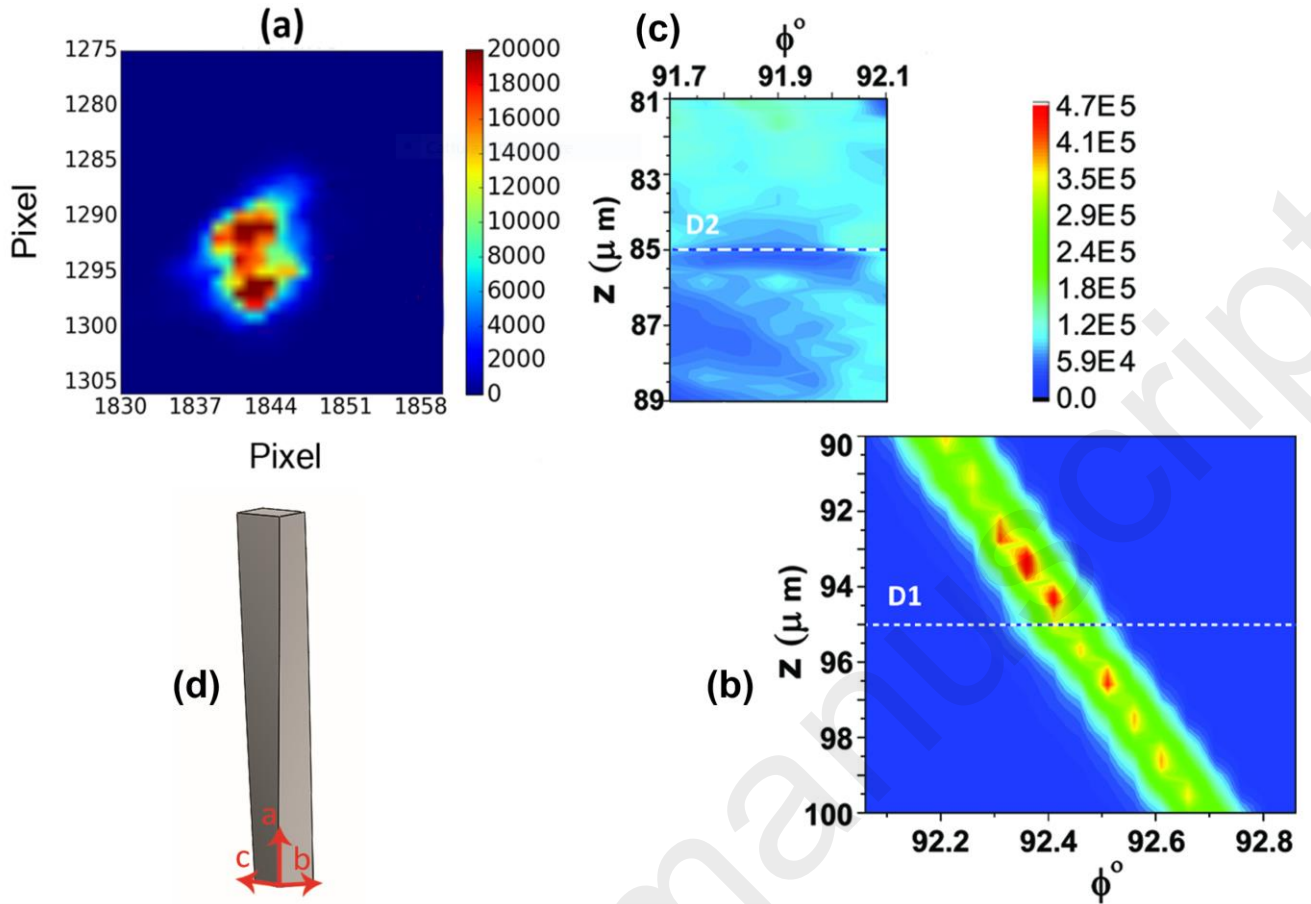


Fig. 3. (a) Maximum intensity projection of the y,z,ϕ -scanning for the peak (006 1) measured in *pristine conditions*. (b) Corresponding localization map, integrated over the y coordinate. Damage position D1 is indicated and corresponds to $z = 95 \mu\text{m}$. (c) Localization map for the same peak obtained with the same integration technique around damage position D2 *after the irradiation*. The damage position is indicated and corresponds to $z = 85 \mu\text{m}$. (d) Geometrical sketch of the crystal twisted along the a -axis as resulting from the measurement in *pristine conditions* (not to scale).

In order to complete the characterization of the region prior to damaging, a y,z -scanning has been acquired around the position D1 at the ϕ value coinciding with the maximum of the rocking curve. Fig. 4(a) shows the maximum intensity projection of this measurement for the same portion of the detector as in Fig. 3(a). Since a close inspection reveals a peak structure consisting of two sub-peaks, we have split the peak area into two regions A1 and A2 corresponding to each sub-peak, as shown in Fig. 4(a). The corresponding localization maps are reported in Fig. 4(b). It is possible to observe that both sub-peaks have originated from the same region centered around position D1 ($z = 95 \mu\text{m}$). This was somehow expected from the fact that the crystal is twisted and the y,z -scanning has been performed at a fixed ϕ value corresponding to the maximum of the rocking curve at position D1 only, nevertheless the spatial coincidence of the two sub-peaks testifies that it is not really possible to describe this situation in terms of different crystal domains.

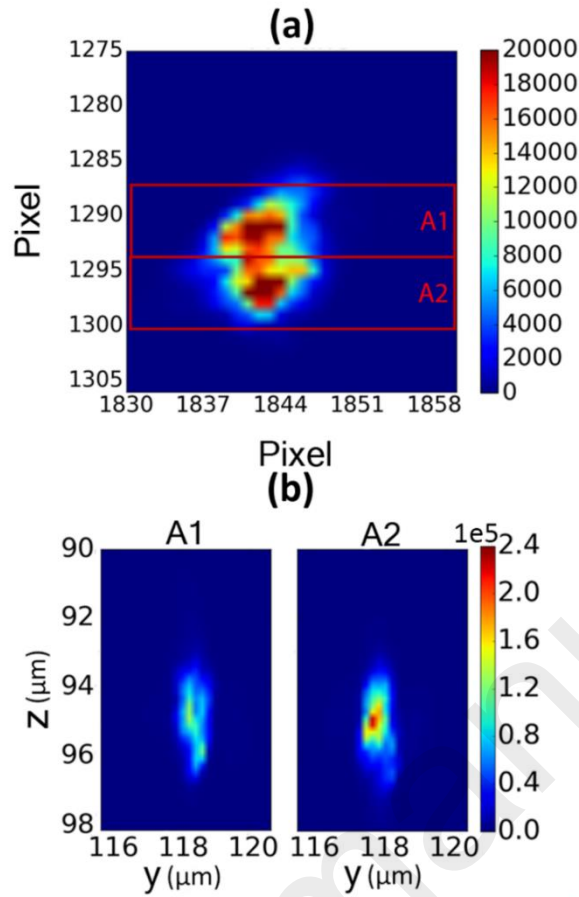


Fig. 4. (a) Maximum intensity projection of the peak (006 1) (the same peak as in Fig.3(a)) at position D1 before irradiation. The definition of the two sub-peak regions A1 and A2 is indicated by the red boxes. (b) Localization maps in real space of the diffraction intensities corresponding to the sub-peaks A1 and A2.

Irradiation position	Irradiation step	Time per point Δt (s)	F (10^8 Jm^{-2})	CF (10^8 Jm^{-2})	D (10^9 Gy)	CD (10^9 Gy)
D1	a	10	3.44	3.44	1.91	1.91
	b	100	34.4	37.8	19.1	21.0
	c	1000	344	382	191	212
D2	a	1000	344	344	191	191

Table I. Parameters of the irradiation procedure used to damage the crystal (see text). Δt is the irradiation time at each point. F and D represent the fluence and the dose delivered at each step, respectively. CF and CD represent the *cumulative* fluence and dose delivered after each step, respectively.

The crystal damage was performed following a single-line pattern along the y direction, with a step size $\Delta y=200$ nm between adjacent irradiation points. Therefore, the irradiated region corresponds to a cross-section of the crystal lying in the crystallographic bc -plane. Each point has been irradiated for

a time Δt , as specified in Table I. In order to explore several orders of magnitude, the irradiation at position D1 has been split into three steps ($\Delta t = 10, 100, \text{ and } 1000 \text{ s}$ for steps D1.a, D1.b and D1.c, respectively), with intermediate y, z -scans for damage characterization.

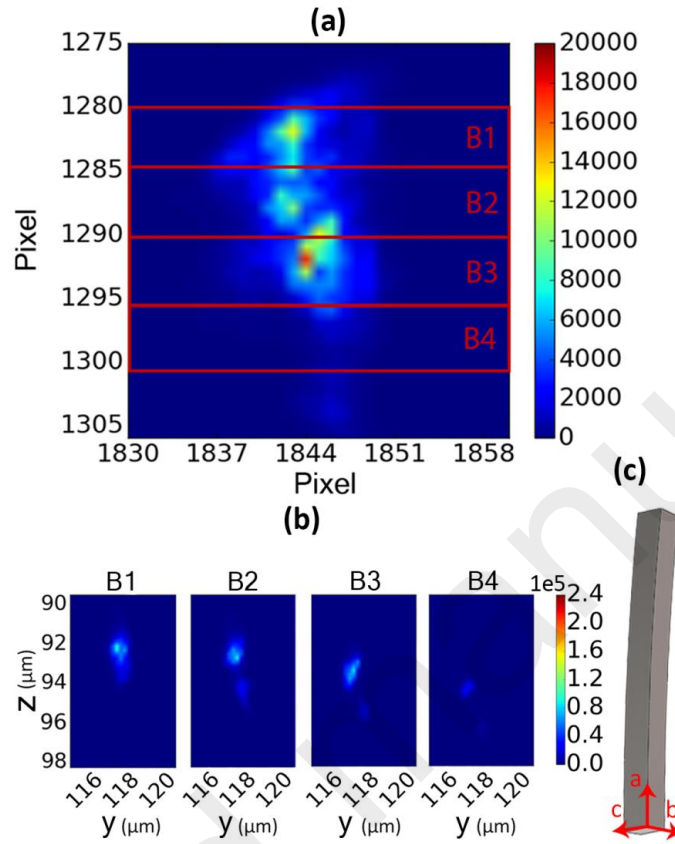


Fig. 5. (a) Maximum intensity projection of reflection (006 1) after irradiation D1.c, i.e. after a cumulative dose $CD = 2.12 \times 10^{11} \text{ Gy}$ and a cumulative fluence $CF = 3.82 \times 10^{10} \text{ Jm}^{-2}$. The definition of the sub-peaks B1, B2, B3 and B4 is highlighted by red boxes. (b) Localization maps in real space of the diffraction intensities corresponding to all of the sub-peaks. (c) Geometrical sketch of the shape of the crystal indicating its bending after irradiation D1.c (not to scale).

No significant changes were detected after D1.a and D1.b irradiation steps in comparison with the pristine conditions. On the contrary, after irradiation D1.c the maximum projection of reflection (006 1) strongly elongates and at least four different sub-peaks can be defined in different areas of the detector (see Fig. 5(a)). The corresponding localization maps are shown in Fig. 5(b): it is possible to observe that with moving from the sub-peak B1 to the sub-peak B4, the maximum of the diffracted intensity progressively shifts from lower z -values towards the irradiation position ($z = 95 \text{ μm}$). This behavior indicates a supplementary twist of the habitus of the crystal as featured in Fig. 5(c): with increasing the cumulative fluence CF (or the cumulative dose CD), its shape tends to bend around the crystallographic b -axis, i.e. around the X-ray beam direction.

The same sample underwent a second damage procedure at another position labelled as D2 ($z = 85 \mu\text{m}$) that was located about $10 \mu\text{m}$ apart from position D1, i.e. far enough for the sample to be supposed in pristine conditions at this position. An offline electrical characterization has taken place between the two irradiation sessions, as it will be discussed later on. After centering the sample at the maximum of the rocking curve, the preliminary characterization of the region around position D2 has been performed by means of a y,z -scan. Fig. 6(a) shows the maximum intensity projection for the same POI already studied in Figures 4 and 5: it can be noticed that its position on the detector has slightly changed because of the sample unmounting and remounting procedures necessary to perform the intermediate electrical characterization. Two sub-peak regions A1 and A2 can be identified in this case, as highlighted by the red boxes in Fig. 6(a). The corresponding localization maps are reported in Fig. 6(b): it is possible to notice that the integrated intensity somehow moves towards higher values of the z -coordinate when passing from the sub-peak A1 to the sub-peak A2, reproducing a situation very similar to the one already observed in Fig. 5(b). This means that at this position D2 the crystal is already bent before irradiation, like the shape shown in Fig. 5(c), with an angular distance between the centroids of the two sub-peaks equal to 0.34° , as calculated from the beam center. We do not have enough data to say whether this curvature was already present even before the irradiation at position D1.

The irradiation procedure at position D2 has followed the same spatial pattern already used for position D1, whereas from the point of view of the time pattern only a single irradiation step D2.a has been performed with $\Delta t = 1000 \text{ s}$, as shown in Table I.

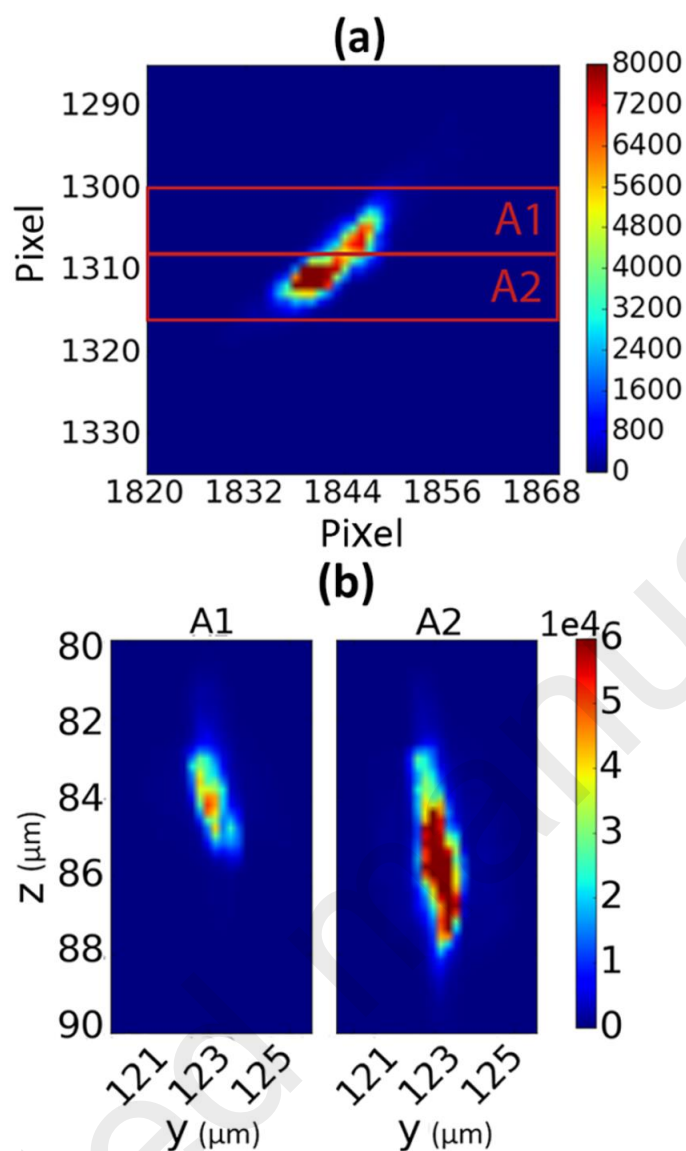


Fig. 6. (a) Maximum intensity projection of reflection (006 1) measured at position D2 before irradiation. The definition of the two sub-peak regions A1 and A2 is highlighted by the red boxes. (b) Localization maps in real space of the diffraction intensities corresponding to the sub-peaks.

The post-irradiation characterization has been performed via another y,z -scan, whose maximum intensity projection is reported in Fig. 7(a). The presence of two separated sub-peaks is clearly visible, with an angular distance between their centroids equal to 1.37° , as calculated from the beam center. This increase in the spread of the crystal mosaicity by about 1° is comparable to what already observed by our group in a previous paper, even if in that case the CF and CD values were at least twentyfold larger.²⁹ However, this observation testifies the appearance of two misaligned crystal domains connected by a [010]-tilted grain boundary.

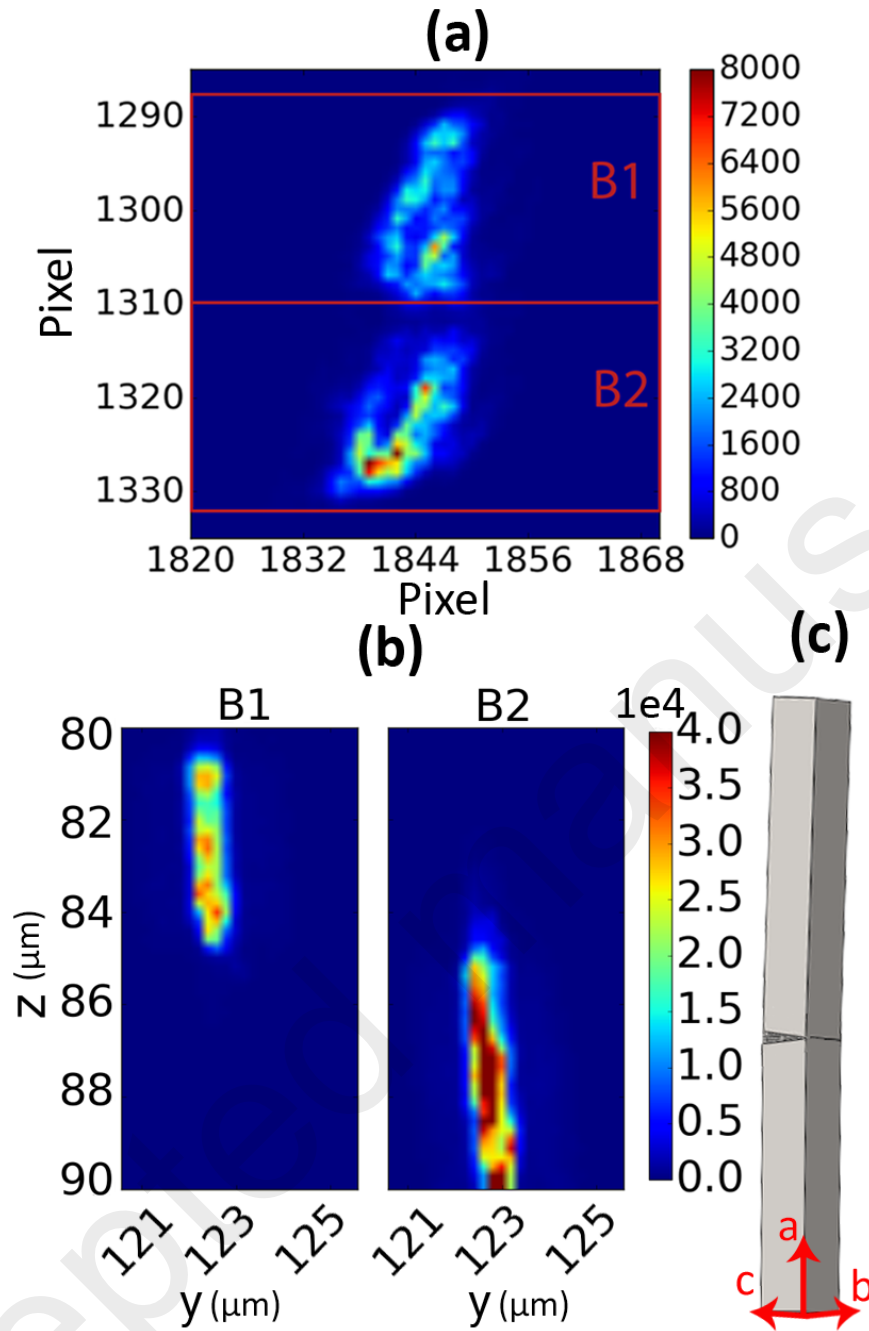


Fig. 7. (a) Maximum intensity projection of reflection (006 1) measured at position D2 after irradiation with a cumulative dose $CD = 1.91 \times 10^{11}$ Gy and a cumulative fluence $CF = 3.44 \times 10^{10}$ Jm^{-2} . The definition of the sub-peaks B1 and B2 is highlighted by the red boxes. (b) Localization maps of the diffraction intensities corresponding to the two sub-peaks. (c) Geometrical sketch of the shape of the crystal after irradiation indicating its division at position D2 ($z = 85 \mu\text{m}$) into two straight domains (not to scale).

The localization maps corresponding to the two sub-peaks of Fig.7(a) are reported in Fig.7(b). The results are very apparent: each sub-peak is completely localized on a single side of the damaged line D2 ($z = 85 \mu\text{m}$), showing that two straight crystallites have emerged from the irradiation of the bent pristine crystal, and that their grain boundary coincides with the irradiated region. This means that

the irradiation has allowed releasing the local mechanical stress present in the crystal, which in turn implies a transient local change of the mechanical properties of the material to have occurred in the irradiated region only. The origin of this change could possibly be represented by thermal fatigue effects induced by the numerous ($\approx 6 \times 10^9$) heating/cooling cycles with $\Delta T=10-30$ K locally induced by the X-ray nanobeam during the irradiation time Δt , which imply corresponding thermal dilation/contraction cycles,¹⁸ or, alternatively, by transient local softening of the chemical bonds taking place in during the irradiation pulses and inducing non-thermal melting in the system.³⁰

As a final XRD characterization step, a y, z, ϕ -scan has been performed around the position D2 after the irradiation. Following the same procedure already used for Fig.3(b), a double-integrated localization map has been obtained and reported in Fig.3(c). Although the data set has been somehow limited because of time constraints, nevertheless some observations can be made. Firstly, the mosaicity spread in this region after the irradiation is much greater than the one observed around position D1 in pristine conditions, with a corresponding FWHM of the rocking curve at fixed z -coordinate that can be estimated as about 0.6° , i.e. one order of magnitude larger. This fact implies that the irradiation also induces the formation of nano-domains in the crystal corresponding to [100]-tilted grain boundaries. Again, this is the same phenomenon already observed by our group in a previous paper for CD and CF values about twentyfold larger, which generated a mosaicity spread equal to about 4° .²⁹ However, in the present experiment the mosaicity increase takes place at a higher rate as a function of irradiation. Indeed, a linear extrapolation of the results of the present experiment to the experimental conditions of Ref.²⁹ would result in a mosaicity of about 12° , which corresponds to a factor of 3 overestimation with respect to the experimental findings. Therefore, the comparison between these two experiments suggests that the relationship between the angular spread of the mosaicity and CD (or CF) should be non-linear, with a lower mosaicity increase induced by higher CD and CF values. As a second observation, it can be noticed that Fig.3(c) shows some loss of diffracted intensity exactly at the irradiation position D2, which could be interpreted as a crystallinity loss occurring at the points where the direct interaction between the X-ray beam and the material takes place. This fact represents an indication of a rearrangement of the atomic positions according to a more disordered pattern after irradiation, whose origins could be the above-mentioned thermal fatigue or non-thermal melting.

Finally, it should be noted that the value of the c -axis lattice parameter obtained from this post-irradiation scan is $c = 30.69(1) \text{ \AA}$, which testifies an UD regime for the crystal that, in spite of the twentyfold lower irradiation dose, is even deeper than the one obtained in our previous experiment.²⁸⁻

3.1 Electrical measurements

Complementary to the structural measurements, also electrical measurements have been performed to characterize the changes in the functional properties of the crystals. For simplicity, only the measurements corresponding to another sample (WBL503) will be discussed, whereas the ones corresponding to the sample that has been thoroughly discussed from the point of view of XRD measurements (WBL524) can be found in the Supplementary Information. This sample has undergone a single damage procedure consisting in an irradiation according a two-line raster scan with $\Delta y=250$ nm and $\Delta z=250$ nm, so that a square mesh was obtained for the impinging points of the beam on the crystal, with an irradiation time per point $\Delta t=500$ s. Because of this geometrical arrangement, the irradiated portion of the crystal can be considered as a single block of homogeneous material with modified electrical properties that is electrically equivalent to a resistor placed in series with another one representing the non-irradiated regions of the crystal with their pristine electrical properties. Analogous electrical models have already been formulated in the past to interpret the photoconductivity effects and the phase instability of Bi-2212 microcrystals.³¹⁻³²

Fig.8 shows the electrical resistance R versus temperature T behavior measured for the sample before and after the irradiation. It is clear that the irradiation has increased the total resistance of the sample, which means that the resistivity of the irradiated part ρ_{irr} is greater than the one of the pristine material ρ . A close inspection of the superconducting transition (see inset of Fig.8) reveals that the zero-resistance critical temperature $T_{c,0}$ has decreased from 71.61 K down to 70.05 K after irradiation, whereas the mean-field critical temperature T_c (defined as corresponding to the peak of the first order derivative) has decreased from 76.72 K to 76.08 K. The overall result of these shifts is the appearance of a longer tail for the superconducting transition, which has already been ascribed in the past to the generation of spatially separated nano-domains with lower local values for T_c and higher values of resistivity in comparison with the pristine material.^{16, 29} These changes in T_c and in resistivity are related to a local decrease in the oxygen non-stoichiometric content δ induced by the beam.²⁹

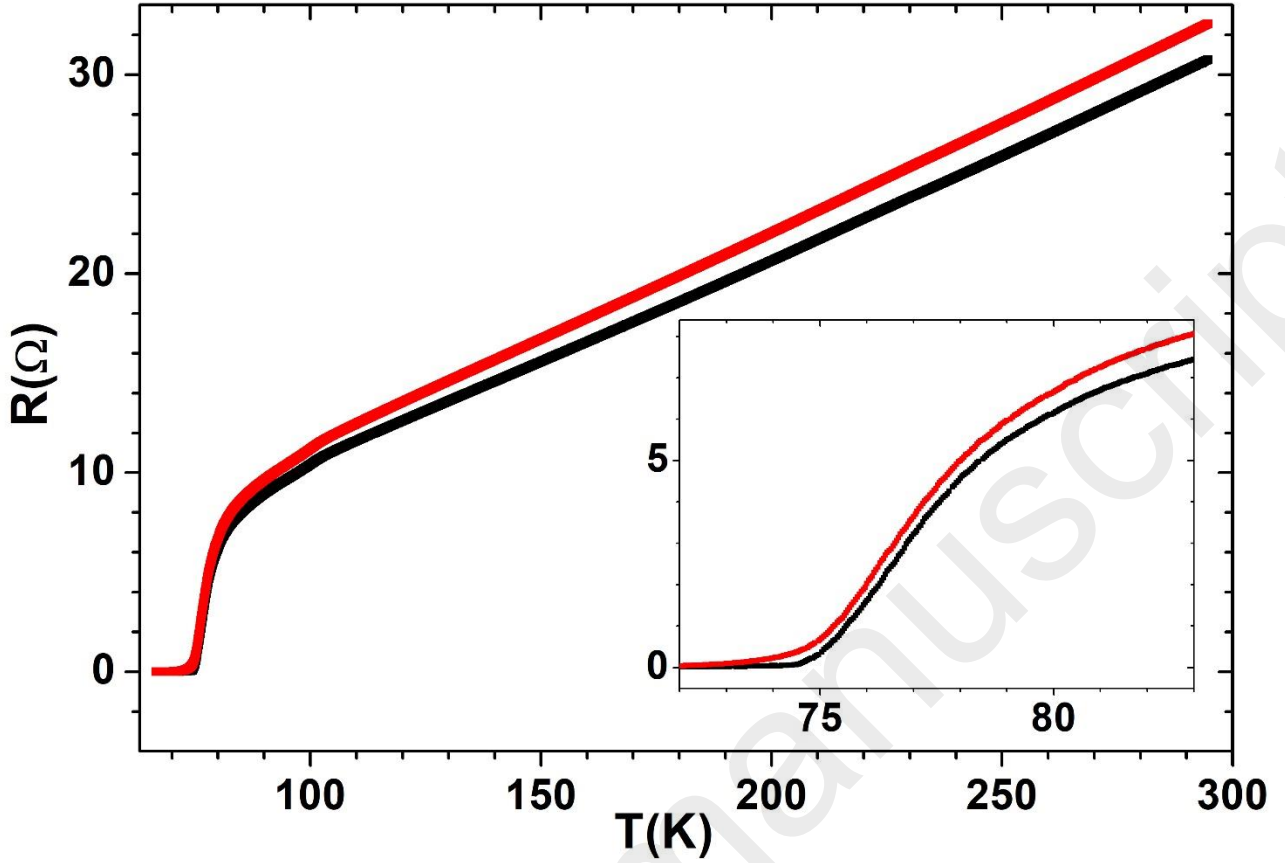


Fig. 8. Resistance R vs temperature T behavior of a representative sample (WBLS03). The black line represents the sample in pristine conditions, the red one refers to the sample after irradiation with cumulative dose $CD = 1.01 \times 10^{11}$ Gy and cumulative fluence $CF = 1.72 \times 10^{10}$ Jm⁻². The inset zooms in the transition region.

Due to the in-series electrical configuration of the pristine and irradiated portions of the crystal, it is possible to determine the electrical resistivity specific to each irradiation state of the material by implementing simple geometrical considerations. Indeed, for the pristine sample $R = \rho \frac{l}{S}$, where ρ is the resistivity of the material in pristine conditions, S is the cross-section area of the sample, and l is the length of the crystal as sensed by the 4-probe configuration. On the other hand, after the irradiation, the total resistance of the sample R_{irr} can be described as $R_{irr} = \rho \frac{l-l_{irr}}{S} + \rho_{irr} \frac{l_{irr}}{S}$, where ρ_{irr} is the resistivity of the irradiated material and l_{irr} is the length of the irradiated portion of the crystal. Since ρ can be determined from the preliminary R vs T and geometrical characterizations, ρ_{irr} can be obtained from the following equation:

$$\rho_{irr} = R_{irr} \frac{S}{l_{irr}} - \rho \frac{l - l_{irr}}{l_{irr}} \quad (1),$$

provided that the length of the irradiated region l_{irr} is known.

Fig.9 shows the comparison between the ρ vs T behaviors of both the pristine materials and the irradiated material as deduced from Eq.(1). The curve of the pristine material corresponds to the typical OD behavior, with its linear behavior in the higher temperature region ($T > 150$ K) and a room temperature resistivity value of about $2 \times 10^{-6} \Omega\text{m}$. This is in agreement with the previous observation stemming from the value of the c -axis about the general OD nature of pristine crystals. On the other hand, the curve corresponding to the resistivity ρ_{irr} after irradiation with cumulative dose $CD = 1.01 \times 10^{11}$ Gy (and cumulative fluence $CF = 1.72 \times 10^{10} \text{Jm}^{-2}$) shows the typical features of the UD regime with the downwards curvature for $T > 150$ K and a room temperature resistivity of about $6 \times 10^{-6} \Omega\text{m}$.³³ This finding confirms what we have already observed from the point of view of the elongation of the crystallographic c -axis about the ability of X-ray nano-beams to induce a decrease of the oxygen non-stoichiometric content δ ,^{9, 29} and complements this fact by establishing a quantitative relationship between the CD (or the CF) and the material resistivity. About the precision and the application limits of the method used for the resistivity data analysis, they can be deduced by means of a close inspection of the ρ_{irr} vs T curve in the region around T_c . As it can be noticed in the inset of Fig.9, a noisy behavior can be detected for the data points in the temperature range $74 \text{ K} < T < 80 \text{ K}$, which clearly corresponds to an experimental artifact. The reason can be easily understood by considering that in the transition region, for a fixed T value, small changes of the T_c 's induce dramatic changes in the values of the resistivity curves, therefore resulting in a subtraction between non-equivalent sample resistivity regimes and thus generating the artifact. These considerations imply that this method can be safely applied only far enough from both T_c values involved in the analysis (i.e. before and after irradiation), which can be determined on a case-by-case basis only.

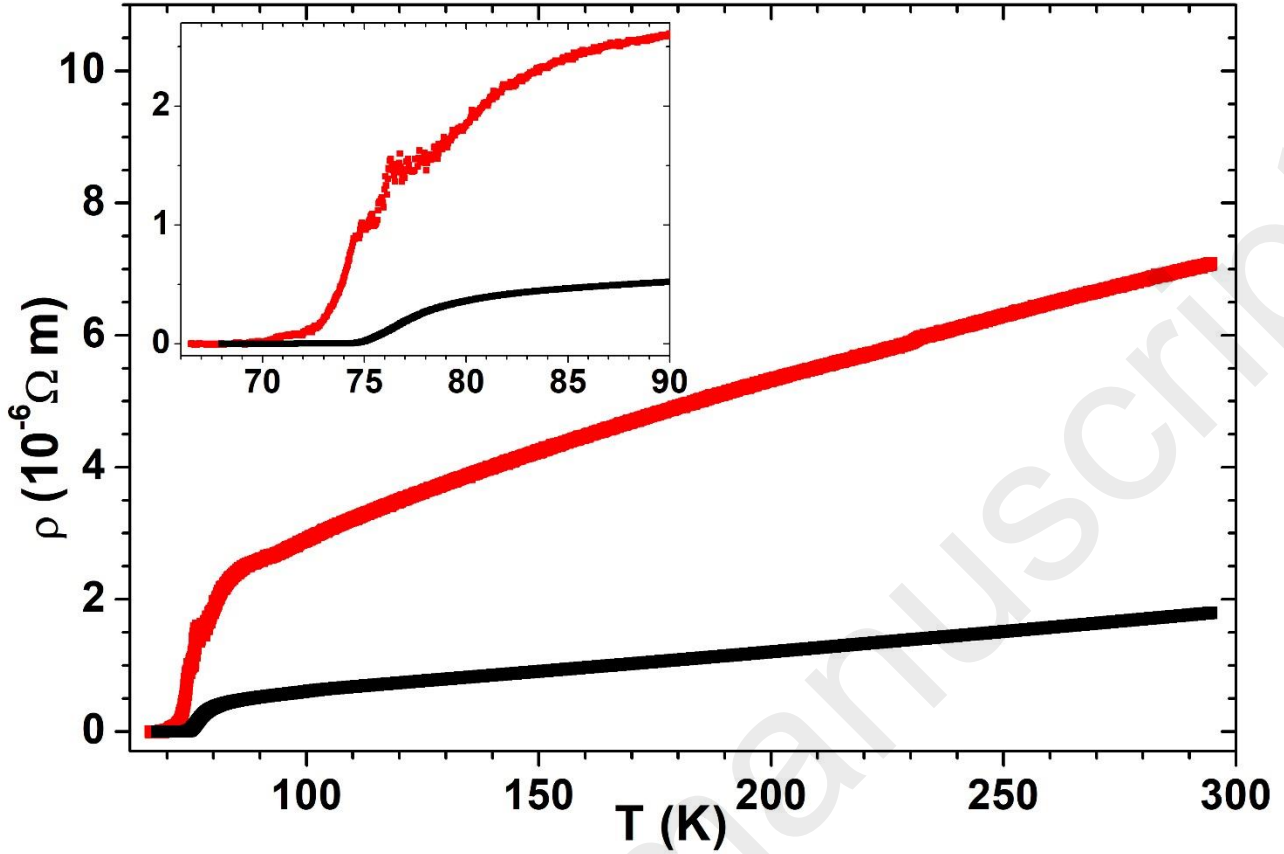


Fig. 9. Resistivity vs temperature behavior of the material corresponding to the sample shown in Fig. 8. The black line represents the resistivity ρ in pristine conditions, the red line represents the resistivity ρ_{irr} after the irradiation with cumulative dose $CD = 1.01 \times 10^{11}$ Gy and cumulative fluence $CF = 1.72 \times 10^{10}$ Jm⁻². The inset zooms in the transition region.

However, the value of the material resistivity at room temperature ($T=295$ K) certainly falls within the reliability range of the analysis for all of the curves, due to its very large distance in temperature from the transition regions. The corresponding values are plotted in Fig.10 as a function of the cumulative dose CD and of the cumulative fluence CF for all of the samples that have completed at least one cycle of the experimental steps from i) to v) listed in Section 2. It is possible to observe that both samples follow the exponential law $\rho = \rho_0 e^{\alpha x}$, where ρ_0 represents the material resistivity in pristine conditions, x can be identified as either CD or CF , and α is the increase rate of the resistivity with irradiation. If CD is chosen as the independent variable (see Fig.10(a)), then the average increase rate $\alpha = (1.48 \pm 0.12) \times 10^{-11}$ Gy⁻¹ can be determined from both samples. On the other hand, if CF is selected as the independent variable (see Fig.10(b)), then $\alpha = (8.4 \pm 0.4) \times 10^{-11}$ J⁻¹m².

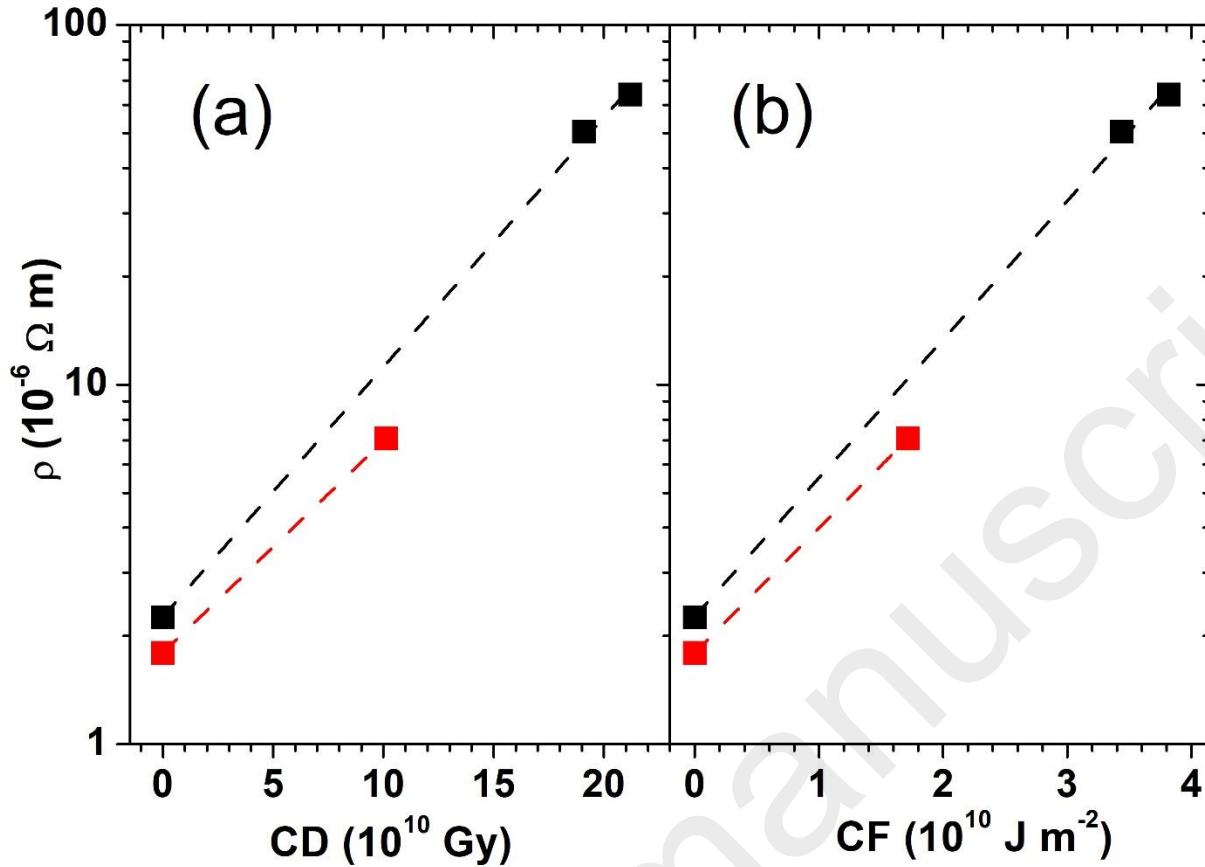


Fig. 10. Resistivity of the Bi-2212 material at room temperature ($T=295$ K) as a function of the cumulative dose CD (a) and of the cumulative fluence CF (b). Red and black colors refer to two different samples (WBL03 and WBL24, respectively). Dashed lines represent the fit to an exponential law for each sample (see text).

This observation of an exponential increase of the resistivity with irradiation deserves some comments. Indeed, it is well-known that a variation of the normal state resistivity, along with corresponding changes in T_c and in the length of the c -axis, is a clear indication of a change in the doping status of high-temperature superconductors. Moreover, it is clear that the possibility of obtaining different doping levels ranging from OD to UD regimes is crucial to fully explore the physical properties of these materials and to clarify the underlying mechanisms responsible for their superconductivity. For instance, in the case of YBCO, a very reliable method has been developed to produce high-purity single crystals that have been extensively used to measure quantum oscillations both in the Hall and in the magneto-resistance.³⁴⁻³⁶ This achievement has been possible also thanks to the availability of a well-defined procedure to produce detwinned single crystals with a homogeneous oxygen content corresponding to the UD regime.³⁷

However, the situation is quite different in the case of Bi-2212. This material can be grown by means of the Travelling Solvent Floating Zone (TSFZ) technique in a highly reproducible way in the form

of OD and optimally doped (OPT) single crystals, but the thermodynamic conditions necessary to obtain the UD regime lay very close to the material decomposition line.³³ Indeed, crystals produced by directly applying a low oxygen partial pressure (minimum $p(\text{O}_2) = 5 \times 10^{-4}$ mbar) during the TSFZ process show a minimum $T_c \approx 76$ K, but with significant segregation of secondary phases like CuO, Bi₂O₃ and (Sr,Ca)₂CuO₃ that indicate a partial decomposition of Bi-2212.³⁸ More often, UD crystals have been obtained by means of a post-annealing stage with very low oxygen partial pressure (or vacuum). Typically, these procedures result in only moderately UD samples with $T_c \geq 65$ K.^{28, 33, 39} This is the reason why the partial substitution of 3+ valence atoms for 2+ cations (e.g. Bi³⁺ for Sr²⁺, or Y³⁺ for Ca²⁺) has been tried several times to induce arbitrary small doping regimes.³⁹⁻⁴³ By means of this technique, it has been possible to systematically explore the full doping range of Bi₂Sr₂Ca_{1-y}Y_yCu₂O₈ from OD to UD all the way down to the insulating behavior, detecting the metal-insulator transition at $y = 0.45$.⁴² In this context, the minimum T_c observed has been $T_c \approx 35$ K, corresponding to $y = 0.42$ and to a room-temperature resistivity $\rho \approx 20 \times 10^{-6} \Omega m$. Similar results ($T_c \approx 50$ K and $\rho \approx 30 \times 10^{-6} \Omega m$ at room temperature) have been obtained by a parallel systematic study.⁴¹ Although we have not performed a systematic study as a function of CD and CF so far, a preliminary comparison between the Bi-2212 properties emerging from our heaviest irradiation conditions (i.e. $T_c \approx 48$ K and $\rho \approx 64 \times 10^{-6} \Omega m$, see also Fig. S5 in the Supporting Information) and the ones obtained by means of cation substitution shows that the UD status induced in our case substantially preserves the same value of T_c even if the normal state resistivity is larger by at least a factor of 2. This observation seems to suggest that, given the same level of normal state resistivity ρ , the Bi-2212 underdoping process via irradiation preserves the superconducting properties more than cation substitution. It is also true that T_c values as low as $T_c \approx 29$ K and $T_c \approx 22$ K have been reported for low $p(\text{O}_2)$ annealing⁴⁴ or mixed cation substitution plus low $p(\text{O}_2)$ annealing⁴³ methods, respectively, but in these cases the absence of normal state resistivity data and the presence of a small Meissner fraction prevent from making a proper comparison with our results. On the other hand, by comparing our measurements to the ones carried out on whisker-like single crystals similar to ours,²⁸ it is possible to observe that the same value of c -axis lattice parameter ($c = 30.69(1)$ Å) in our case corresponds to a T_c value that is at least 20 K less than what can be obtained by means of ordinary annealing processes. This seems to indicate that X-ray irradiation has a much stronger effect on the UD status of single crystals compared to ordinary low-pressure annealing procedure. Therefore, our X-ray irradiation method sets between the cation substitution and the low $p(\text{O}_2)$ annealing procedures in terms of power to modify the Bi-2212 properties. Consequently, it is worth further investigation, since it could offer a unique opportunity to access highly UD superconducting regimes with peculiar features that are not available otherwise.

Finally, it should be noted that, from the point of view of the X-ray nanopatterning, the exponential dependence of the resistivity on the irradiation represents the phenomenological basis that has allowed us to produce Josephson devices¹⁶ and that sets the framework for both limits and opportunities in terms of possible resistivity contrast to be achieved in the future developments of this method.

4. Conclusions

We have carefully characterized superconducting Bi-2212 crystals by means of an X-ray nano-beam and of scanning methods exploiting short exposure times. We have also irradiated selected portions of the crystals up to cumulative doses of the order of 10^{11} Gy and cumulative fluences of the order of 10^{10} Jm⁻² by means of long exposure times. It has turned out that these localized irradiations can bend the crystals or, if some bending is already present, can induce the stress release via the appearance of grain boundaries and spatially separated crystal domains. We have observed that irradiated regions undergo a decrease in their degree of crystallinity and feature an increase in their mosaicity spread. Thanks to the well-defined geometry of the crystals and their mounted-on-chip configuration, we have also been able to determine the resistivity versus temperature curves corresponding to any irradiation stage of the material by means of a subtraction method. This has allowed us to observe for the first time an exponential dependence of the Bi-2212 resistivity on the irradiation dose or fluence, which opens the way towards very interesting opportunities to access highly UD superconducting regimes for this material. We think that these results represent an important step towards the development and the reliability of the X-ray nanopatterning technique.

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Supporting Information. Details about XRD experimental setup, peak indexing and localization, additional electrical measurements and data treatment for the multiple irradiation case.

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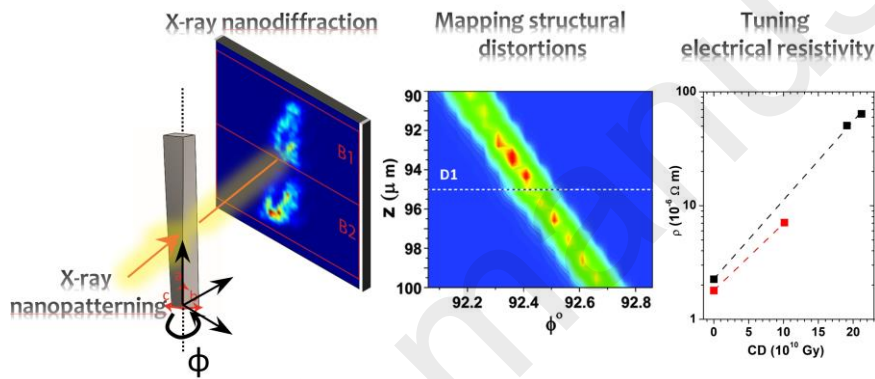
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Mapping of structural changes induced by X-ray nanopatterning via nano-XRD and corresponding electrical effects

by

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Synopsis

X-ray nano-beams can modify in a controlled way the high- T_c superconductor $\text{Bi}_2\text{Sr}_2\text{CaCu}_2\text{O}_{8+\delta}$. Space-resolved nano-XRD mapping and electrical measurements show an increase in mosaicity spread and a release of the mechanical stress with increasing the irradiation dose, along with an exponential increase of the normal-state resistivity. Strongly underdoped regime has been achieved.